

862.C2167



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Not Assigned
SHINICHI HARA, ET AL.	)	
	:	Group Art Unit: 2851
Application No.: 09/818,625	)	
	:	
Filed: March 28, 2001	)	
	:	
For: EXPOSURE APPARATUS, GAS	)	June 28, 2001
REPLACEMENT METHOD,	:	
SEMICONDUCTOR DEVICE	)	
MANUFACTURING METHOD,	:	
SEMICONDUCTOR MANUFACTURING)	:	
FACTORY, AND EXPOSURE	:	
APPARATUS MAINTENANCE	)	
METHOD	:	

Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

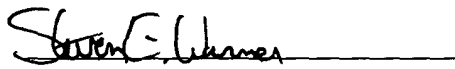
Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

Applicants request that the cited information be considered by the Examiner and that an initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
Attorney for Applicants

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